

Docket No.: 0649-0901P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takeshi MISAWA

Application No.: 10/620,461

Confirmation No.: 009184

Filed: July 17, 2003

Art Unit: 2811

For: SEMICONDUCTOR DEVICE AND
METHOD FOR MANUFACTURING THE
SAME

Examiner: T. F. Tran

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 30, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Title begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.